

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/810,020	LIN, HENRY C.
Examiner	Art Unit	
Rodney P. Swartz, Ph.D.	1645	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
424	9.2	1/3/2006	RPS
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424	116		
424/278,1,439; 426/2,71,658,800,801; 435/4,29			